

Docket No.: 4425-320

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

:

Chien-Hsin LAI *et al.*

: Confirmation No. 3535

U.S. Patent Application No. 10/659,258

: Group Art Unit: 1763

Filed: September 11, 2003

: Examiner: Karla A Moore

For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE  
MATCHING

**SUPPLEMENTAL RESPONSE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Remarks are in furtherance of the Amendment filed August 18, 2006 in response to the Office Action of May 18, 2006.